Search Notes			

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/605,215	CHEN ET AL.	
Examiner	Art Unit	•
 Junghwa M. Im	2811	

SEARCHED				
Class	Subclass	Date	Examiner	
257	666	2/5/2005	JMI	
	778			
	797			
	738			
	738			
	773			
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		-		

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	

SEARCH NOTES (INCLUDING SEARCH STRATEGY)			
	DATE	EXMR	
EAST (USPAT, USPUB, EPO, JPO, DER)	2/5/2005	JMI	
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